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Sheet 1

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INFORMATION DISCLOSURE STATEMENT BY APPLICANT

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Complete if Known			
Application Number	10/827,252		
Filing Date	April 20, 2004	•	
First Named Inventor	Mohiuddin Mala		
Art Unit	2873		
Examiner Name	William C. Choi		
Attorney Docket Number	14682		

		·	U.S. PATENT	DOCUMENTS	
Examiner Initials *	Cite No. 1	Document Number Number-Kind code ^{2 (If known)}	Publication Date MM-DD-YYY	Name of Patentee or Applicant of Cited Document	Page, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
WC	AA	US-6,454,421 B2	Sep. 24, 2002	Yu et al.	
<u> </u>	AB	US-2002/0012180 A1	Jan. 31, 2002	Yu et al.	
	AC	US-6,315,423 B1	Nov. 13, 2001	Yu et al.	
	AD	US-5,579,148	Nov. 26, 1996	Nishikawa et al.	
	AE	US-6,984,917 B2	Jan. 10, 2006	Greywall et al.	
7/	AF	US-6,690,850 B1	Feb. 10, 2004	Greywall	
$-\Psi$	AG	US-6,392,220	May 21, 2002	Slater et al.	
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	FOREIGN PATENT DOCUMENTS						
	Cite		Publication Date	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages		
Initials *	No. '	Country Code ³ Number ⁴ Kind Code ⁵ (if known)	MM-DD-YYYY		Or Relevant Figures Appear	Τ ^δ	
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1	Examiner Signature	/William Choi/	Date Considered	06/23/2006

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Translation is attached.

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INFORMATION DISCLOSURE STATEMENT BY APPLICANT

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Sheet 2 2

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Art Unit	2873	
Examiner Name	William C. Choi	
Attorney Docket Number	14682	

	1 0"	NON PATENT LITERATURE DOCUMENTS	T
Examiner nitials *	ials * No. 1 the item (book, magazine, journal, serial, symposium, catalog, etc.), date, pages), volume-issue number(s), publisher, city and /or country where published.		Τ²
WC AH Johanna I. Young, et al.; COMPARATIVE STUDY OF 2-DOF MICROMIRRORS FOR PRECISION LIGHT MANIPULATION; SPIE Smart Structures and Materials Conference, Newport Beach, CA, March 4-7, 2001.		□	
	Al	Velijko Milanovic, et al.; MONOLITHIC HIGH ASPECT RATIO TWO-AXIS OPTICAL SCANNERS IN SOI; 2003 MEMS Conference, Kyoto, Japan, January 19-23, 2003, pp. 255-258.	C
	AJ	Sunghoon Kwon, et al.; LARGE-DISPLACEMENT VERTICAL MICROLENS SCANNER WITH LOW DRIVING VOLTAGE; IEEE Photonics Technology Letters, Vol. 14, No. 11, November 2002, pp. 1572-1574.	
1	AK	D.A. Horsley et al.; MULTI-DEGREE OF FREEDOM DYNAMIC CHARACTERIZATION OF DEEP- ETCHED SILICON SUSPENSIONS; Solid State Sensor and Actuator Workshop, Hilton Head, June 4-8, 2000, pp 81-84.	כ
	AL	B.M. Evans et al.; FINITE ELEMENT MODELING OF MICROMACHINED MEMS PHOTON DEVICES; Miniaturized Systems with Micro-optics and MEMS, Santa Clara, September 1999, SPIE 3878, pp 253-260.	
V	АМ	David Burns, et al.; OPTICAL BEAM STEERING USING SURFACE MICROMACHINED GRATINGS AND OPTICAL PHASED ARRAYS; Optical Scanning Systems: Design and Application, San Diego, CA, July 1997, SPIE 3131, pp. 99-110.	ב
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Examiner /William Choi/	Date Considered	06/23/2006
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